

Corres. and Mail BOX AF

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C.B -

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2125

00862.022199.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
	: Examiner: P. L. Rodriguez
Keiji EMOTO)
	: Group Art Unit: 2125
Application No.: 09/833,766)
	: Confirmation No.: 4154
Filed: April 13, 2001)
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,	:) April 2, 2004
ELECTRON BEAM LITHOGRAPHY	
APPARATUS, EXPOSURE APPARATUS,	RECEIVED
EXPOSURE APPARATUS MAINTENANCE	:
METHOD, SEMICONDUCTOR DEVICE) APR 0 7 2004
MANUFACTURING METHOD, AND SEMI-	Technology Center 2100
CONDUCTOR MANUFACTURING FACTORY) Tentilology Oction 2100

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated February 5, 2004, please amend the above-identified application as follows pursuant to 37 C.F.R. § 1.116:

polos/y

Entry Not Recommended

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